

Automated Extraction of Synthesis Data from Unstructured Scientific Literature

SURGE

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Filter Pruning

 $k \in K(x')$

Election Talk

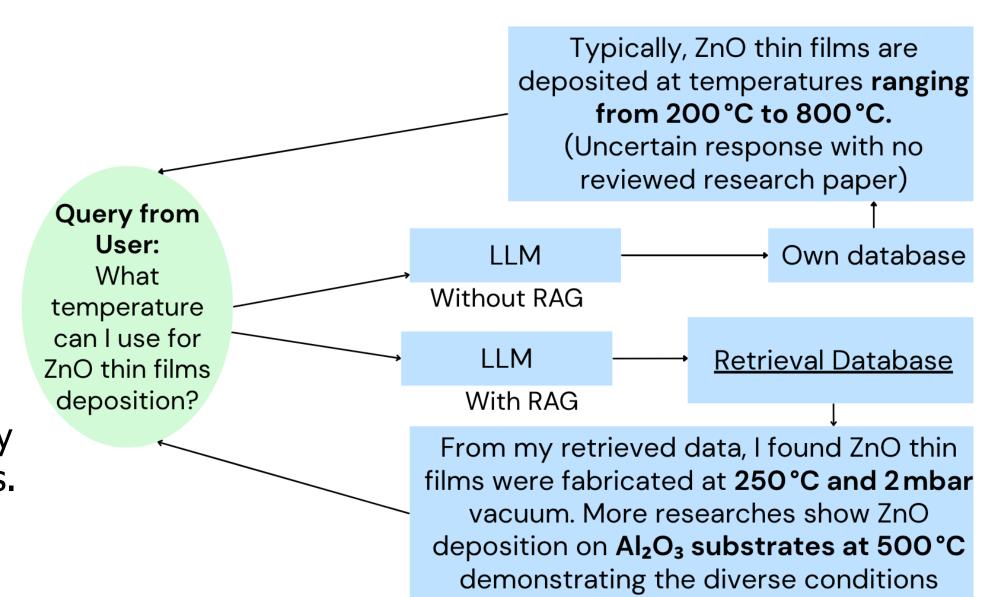
Elon Party

 $\text{kw_score}(p_i) = \sum_{k \in p_i} \mathbf{1}_{k \in p_i}$

RAG in Scientific Literature

- Pulsed Laser Deposition, a highly precise and versatile thin film technique for film fabrication or material deposition.
- Manual scientific literature review and extraction for research parameters is an inefficient and slow process.
- Accurate retrieval is crucial to prevent hallucinated or misleading output, especially in research and experiments.
- NLP with RAG enhances experimental data retrieval.

How RAG works?



Tools Used

sentence-transformers pinecone-client selenium beautifulsoup4 undetected-chromedriver requests

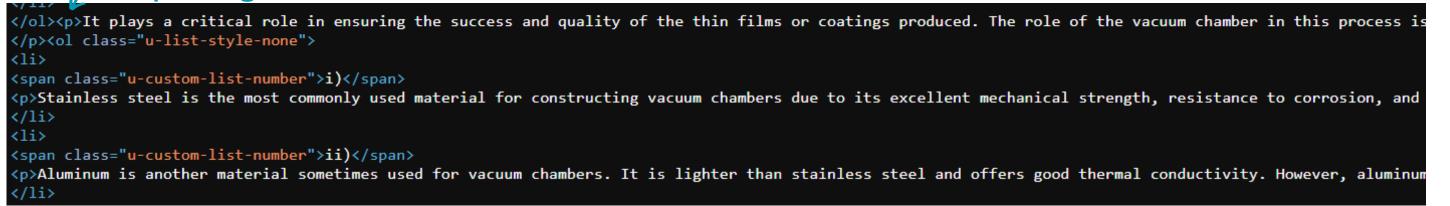
Google-generativeai Gemini 1.5 flash API Pincone DB API Springer API ModernBERT **MatSciBERT**

numpy = 1.24.4matplotlib scikit-learn Ollama LLaMA Phi-3 mini

Paragraph Extraction

- Extracted tags from HTML full texts
- Filtered out non-essential content (e.g., headers, references)
- Generalized for every topic; Generalized HTML parser

tags from HTML



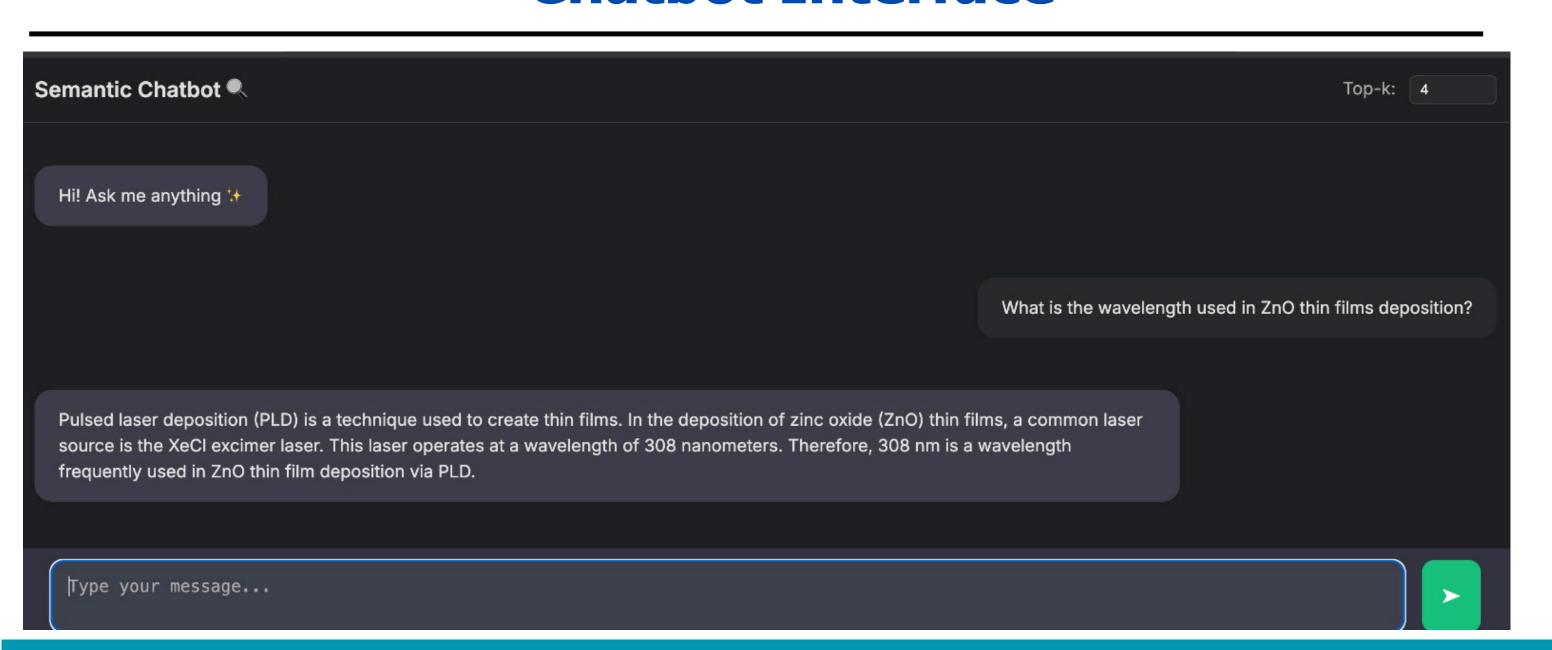
Sources:

- 1. Springer API (https://dev.springernature.com)
- 2. Automated springer webscraper (Please stick to website's user policy)

Pulsed Laser Deposition (a case study):

- 1. Scraped and Parsed about 4000 paragraphs related to Pulsed Laser Deposition (PLD)
- 2. Classifier using TF-IDF vectorizer and Logistic Regression classifier model configuration
- 3. Augmented with external 1000+ paragraphs, all marked 1
- 4. Choose top-k paragraph according to the need and the depth of the chatbot response

Chatbot Interface



Retrieval System

Embedder used: ModernBERT, MatSciBERT; ModernBERT outperformed MatSciBERT Database of 9000+ paragraphs, all related to PLD experiements and related researches Cloud based vector database (pinecone.io) storing ModernBERT embeddings

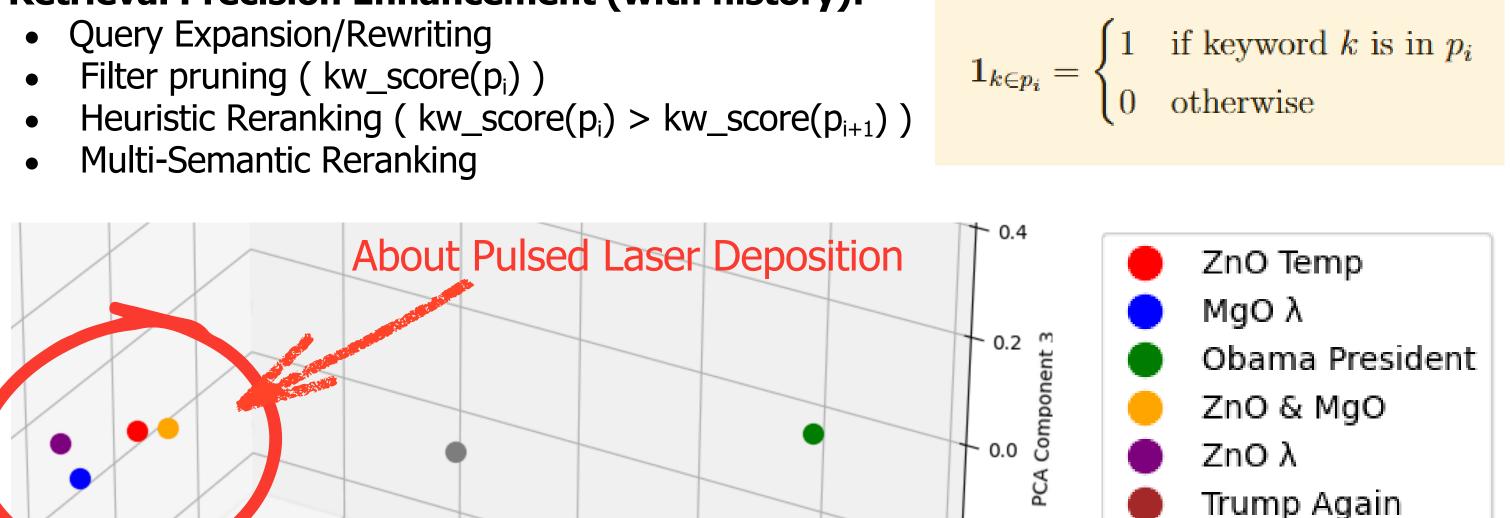
Semantic Search:

- 1. Query Expansion
- 2. Single Semantic Search ranking

Deep Search:

Retrieval Precision Enhancement (with history):

- Query Expansion/Rewriting
- Filter pruning (kw_score(p_i))

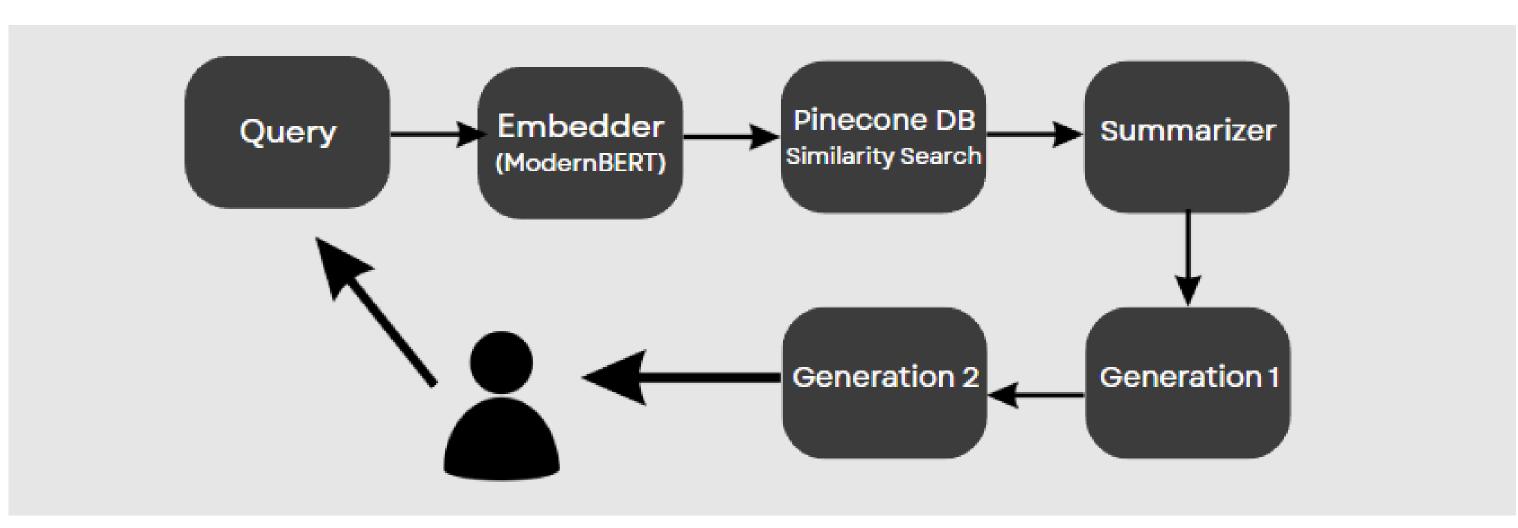


3D representation of n dimension ModernBERT embedding after dimensional reduction

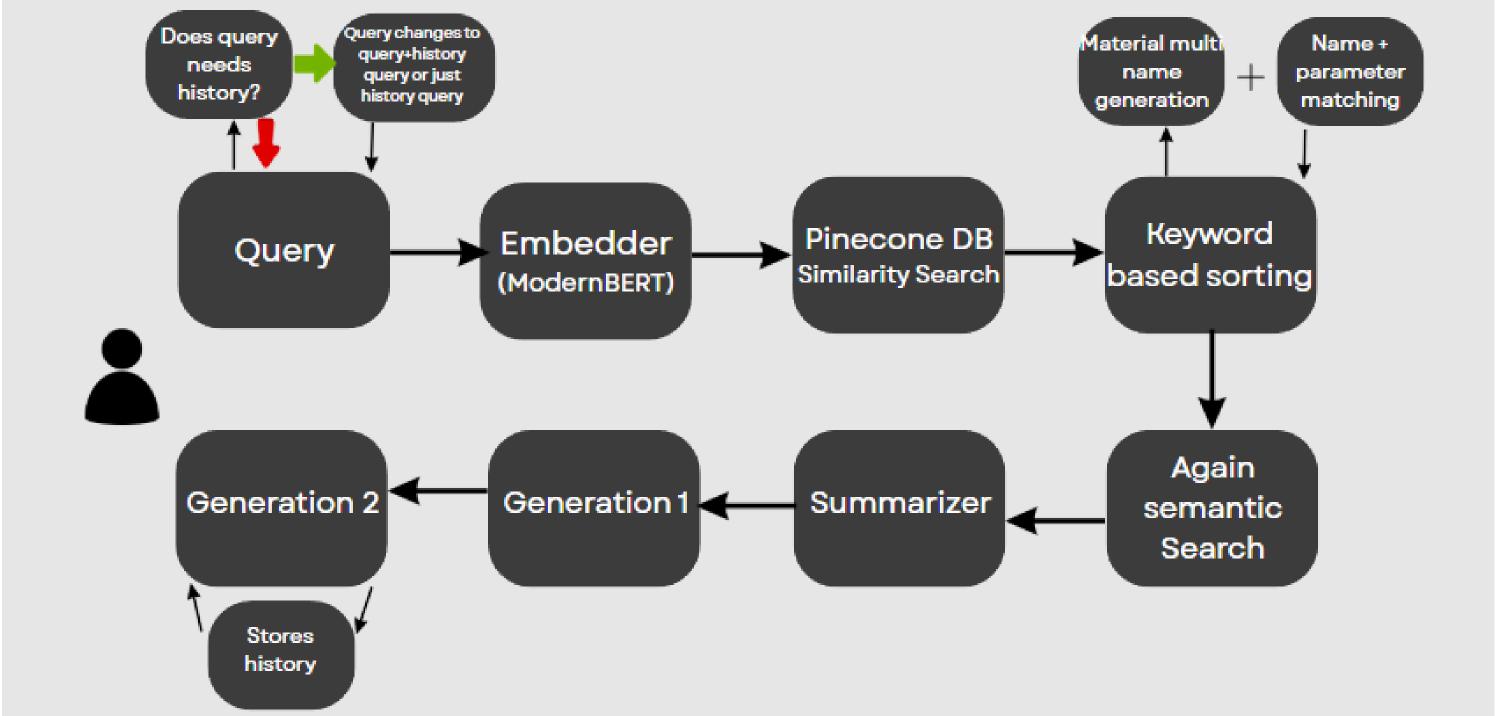
Generation Pipelines

Utilizes Retrieval Augmented Generation Leverages Gemini-1.5 flash with Pinecone DB

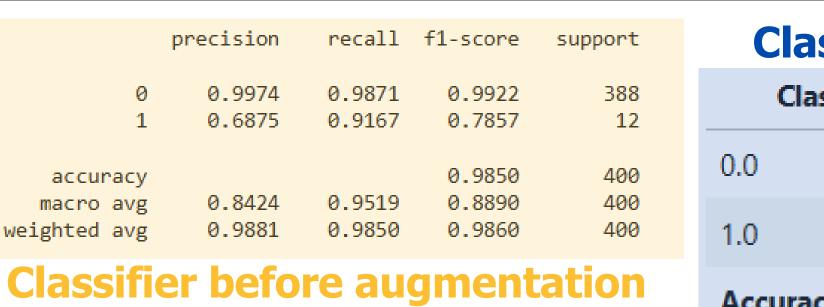
Semantic Only:



Heuristic Reranking + Filter Pruning + Query-Expansion + Multi-semantic reranking Deep Search:



Results



	Predicted 0	Predicted 1	
			Confusion
Actual 0	413	10	Matrix
			after
Actual 1	10	216	augmentation
			3.3

Classifier after augmentation							
Class	Precision	Recall	F1-Score	Suppor			
0.0	0.9764	0.9764	0.9764	423			
1.0	0.9558	0.9558	0.9558	226			
Accuracy			0.9692	649			
Macro Avg	0.9661	0.9661	0.9661	649			
Weighted Avg	0.9692	0.9692	0.9692	649			
AUC-ROC : 0.99742268041							

Semantic Search:

Example Query: What is the wavelength used in ZnO thin films?

Pulsed laser deposition (PLD) of zinc oxide (ZnO) thin films utilizes various laser wavele ngths. Studies have employed a XeCl excimer laser at 308 nanometers (nm). Other research utilizes a KrF excimer laser operatrious laser wavelengths.rious laser wavelengths. Stud ies harious laser wavelengths. Studies have employed rious rious laser rious laser rious rious rious rious rious rious rious laser wavelerious rious rious laser wavelengths. Studies have employed a XeCl excimer lasrious rious rious rious laser wavelengths. Stud rious laser wavelengths. Studies have employed a XeCl excimer laser at 308 nanometers (nm Other research utilizes a KrF excimer laser operating at 248 nm. Furthermore, some ex periments have used a system capable of 1064 nm and 532 nm wavelengths. The choice of wav elength significantly impacts the deposition process and resulting film properties.

Deep Search (Keyword enhanced Multi-Semantic):

Example Query: What is the MgO deposition temperature?

Bot said 🗃: Based on my analysis of available data regarding magnesium oxide (MgO) deposition, there's no single definitive answer to the query "what is the MgO deposition temperature?". The optimal temperature is highly contingent on the specific deposition method employed and the desired properties of the resulting MgO film. My findings reveal a considerable range of temperatures reported across various studies.

akin to molecular beam epitaxy (MBE). Critically, a subsequent high-temperature annealing step (650-740°C) followed this deposition, but this is a separate process for modifying the film after its initial creation not the deposition temperature itself.

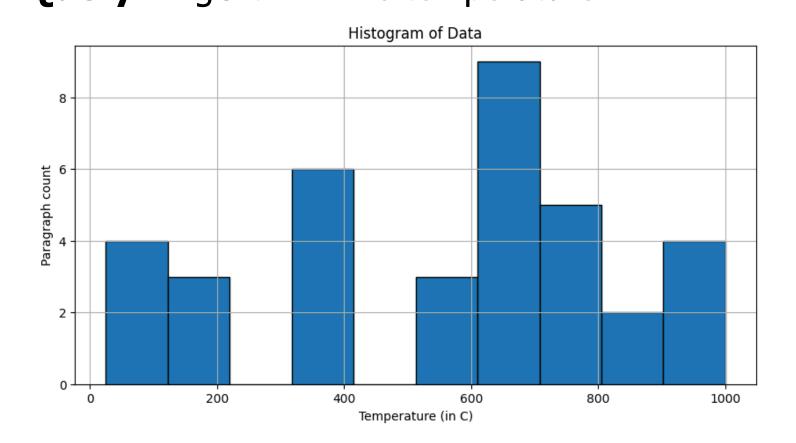
One study detailed the deposition of a 20 Å MgO(111) film at 140°C. This deposition utilized a technique

Other research explored MgO deposition via pulsed metalorganic chemical vapor deposition (MOCVD). This method involved a significantly broader temperature range, spanning 500-750 K (227-477°C). This wide variation suggests that the precise temperature within this range is fine-tuned based on factors not explicitly detailed in the available data, such as specific precursor gases or desired film characteristics

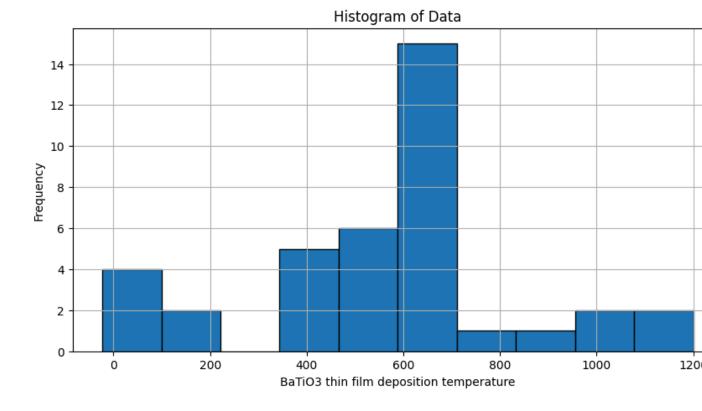
Several reports mention temperatures related to substrate preparation rather than the MgO film deposition. For example, MgO(100) substrates were pre-annealed at temperatures ranging from 1000°C down to 550°C (in one case, utilizing spray pyrolysis for substrate creation), but these are pre-treatment steps unrelated to the actual MgO film deposition temperature. In another instance, MgO(100) and MgO(111) substrates were radiatively heated, but the specific temperature remained unreported. Another study mentions MgO(100) substrates used for deposition, but again, omits the actual deposition temperature for the film itself.

Histogram Plotter:

Query: MgO thin films temperature



Query: BaTiO3 thin films temperature



References

- https://arxiv.org/html/2410.19572
- https://doi.org/10.1038/s41467-024-45563-x
- https://doi.org/10.1039/D4DD00051J